

Form PTO 1449  
(Modified)U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

ATTY DOCKET NO.

277078US0PCT

SERIAL NO.

10/550,534

## LIST OF REFERENCES CITED BY APPLICANT

APPLICANT

Kentarou TAMAKI, et al.

FILING DATE

September 22, 2005

GROUP

2874

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
/MJS/	AO	JP 2000-66051	3/3/2000	Japan (with English Abstract)		X
	AP	JP 2001-83342	3/30/2001	Japan (with English Abstract)		X
	AQ	JP 63-194206	8/11/1988	Japan		X
	AR	JP 61-260208	11/18/1986	Japan		X
	AS	WO 03/010603 A1	2/6/2003	WIPO (with English Abstract)		X
	AT	JP 10-268158	10/9/1998	Japan (with English Abstract)		X
	AU	CN 1285667 A	2/28/2001	China		X
	AV					

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)

/MJS/	AW	Kentarou TAMAKI, et al. " Photolithographic Properties of Photosensitive Sol-gel Materials and their Application to Optical Waveguides", Journal of Photopolymer Science and Technology Volume 15, Number 1, 2002, Pages 103-108				
	AX					
	AY					
	AZ					<input type="checkbox"/> Additional References sheet(s) attached

Examiner

/Michael Stahl/

Date Considered 01/27/2008

\*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.